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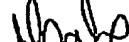
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100176)

First Inventor: Roland K. Sevilla
 Serial No.: 10/601,601
 Filing Date: 06/23/2003
 Title: POLISHING PAD FOR
 ELECTROCHEMICAL-
 MECHANICAL POLISHING
 Examiner: Maurina T. Rachuba
 Art Unit: 3723

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I, Mariejose Monsalve, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on 29 Nov 06.



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 P.O. Box 1450
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RESPONSE TO Office Action

This is a reply to the Office Communication mailed November 1, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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